

Notice of References Cited	Application/Control No. 10/642,271	Applicant(s)/Patent Under Reexamination YAMADA ET AL.	
	Examiner Marianne L. Padgett	Art Unit 1762	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,893,677 B2	05-2005	Yamada et al.	427/238
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*	D	US-6,337,032 B1	01-2002	Chivukula et al.	252/62.9R
*	E	US-5,935,638 A	08-1999	Chandra et al.	427/58
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*	G	US-3,809,944	05-1974	Jongerius et al.	313/485
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	U	"Laser Micro-Fabrication of Waveguide Devices", IBM Technical Disclosure Bulletin, Volume 31, #11, April 1, 1989, Pages 150-152.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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